FORM PTO-1449		Docket Number (Optional) YOR920000186US2	Application Number Not yet assigned
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		Applicant Kagan et al.	
		Filing Date Concurrently herewith	Group Art Unit ~~Not yet assigned~~ 1734

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
S AL	4,916,115	4/10/90	Mantese et al.	505	1	
SPC	4,952,556	8/28/90	Mantese et al.	505	1	
SPC	5,059,258	10-1991	Wefers et al.	148	272	
SPC	5,512,131	7/30/96	Kumar et al.	156	655.1	
SPC	5,620,850	4/15/97	Bamdad et al.	530	300	
S PC	5,900,160	5/4/99	Whitesides et al.	216	41·	
SPC	6,020,047	2/1/00	Everhart	428	209	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	Translation NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

SPC	*"Organic-Inorganic Heterostructure Electonluminescent Device Using a Layered Perovskite Semiconductor ($C_6H_5C_2H_4NH_3)_2PbI_4$",* Era et al., Appl. Phys Lett. 65 (6), 8 August 1994, pp. 676-678.
SPC	*"Manipulation of the Wettability of Surfaces on the 0.1- to 1-Micrometer Scale Through Micromachining and Molecular Self-Assembly",* by Abbott et al., Science, Vol. 257, 4 Sept. 1992, pp. 1380-1382.
SPC	*"Maskless Photolithography: Embossed Photoresist as its own Optical Element",* Paul et al., Applies Physics Letters, Vol. 73, No. 20, 16 November 1998, pp. 2893-2895.
SPC	"Patterning of Dielectric Oxide Thin Layers by Microcontact Printing of Self-Assembled Monolayers", Jeon et al., J. Mater. Res., Vol. 10, No. 12, December 1995, pp. 2996-2999.

EXAMINER Chan Sing Po	DATE CONSIDERED 10/12/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.